



PATENT APPLICATION  
Docket No. 2522-040  
Client No. AW8072US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Jae-Jong HAN, et al.

Serial No. 10/672,884

Examiner: Lee, Hsien Ming

Confirmation No. 9537

Filed: September 26, 2003

Art Unit: 2823

For: METHOD OF FORMING A GATE ELECTRODE, METHOD OF  
MANUFACTURING A SEMICONDUCTOR DEVICE HAVING  
THE GATE ELECTRODE, AND METHOD OF OXIDIZING A  
SUBSTRATE

MAIL STOP AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT

This paper is responsive to the Office Action mailed on 22 June 2004.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 6 of this paper.